

CONSIDERED: /P.T.R./

033082M342

PATENT

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant(s): Shigeo ASHIGAKI, et al.

International Application No.: PCT/JP2005/003392

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U.S. Serial No.: ~~To Be Assigned~~ 10/591345 Group Art Unit: ~~To Be Assigned~~ 1795

Filed: : Herewith

Examiner: ~~To Be Assigned~~
Ponder N. Thompson-Rummel

For: PEELING-OFF METHOD AND REWORKING METHOD OF RESIST FILM

INFORMATION DISCLOSURE STATEMENT

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450


Sir:

Pursuant to the duty of disclosure under 37 C.F.R. 1.56, Applicants are enclosing an Information Disclosure Citation Form (PTO-1449) which lists one of the documents noted in specification (U.S. Patent No. 6,316,167) and the documents noted in the International Search Report (ISR) filed herewith. Copies of the non-U.S. cited documents are enclosed. According to the Search Report, U.S. Patent No. 6,159,646 is a family member of JP 11-109654, U.S. Patent Publication No. 2003/0155077 is a family member of JP 2003-243295, Patent Publication 2003/0190550 is a family member of JP 2003-122009, U.S. Patent Publication 2002/0160590 is a family member of JP 2002-359352, U.S. Patent Publication No. 2003/0170993 is a family member of JP 2003-229481 and U.S. Patent Publication No. 2003/0157806 is a family member of JP 2003-167345.

It is respectfully requested that the cited documents be considered by the Examiner in the above-identified patent application and that the cited documents be made officially of record therein. It is further requested that a listing of the same appear on the face of any patent which may issue from this application.

Respectfully submitted,
SMITH, GAMBRELL & RUSSELL, LLP

By:


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August 31, 2006

ALL REFERENCES CONSIDERED EXCEPT WHERE LINED THROUGH. /P.T.R.

IAP9 Rec'd PCT/PTO 31 AUG 2006

FORM PTO-1449 INFORMATION DISCLOSURE STATEMENT	ATTY. DOCKET 033082M342	SERIAL NO. To Be Assigned 10/591345
	APPLICANT: Shigeo ASHIGAKI, et al.	
	FILING DATE Herewith	GROUP ART UNIT To Be Assigned 1795

U.S. PATENT DOCUMENTS

Examiner's Initials		DOCUMENT NUMBER	DATE	NAME	CLASS	SUB-CLASS	FILING DATE, IF APPROPRIATE
/P.T.R./	AA	6,316,167	11/13/01	Angelopoulos, et al.	430	313	1/20/2000
/P.T.R./	AB	6,159,646	12/12/00	Jeon et al.	430	30	9/4/1998
/P.T.R./	AC	2003/0155077	8/21/03	Hisai, et al.	156	345.32	1/24/2003
/P.T.R./	AD	2003/0190550	10/9/03	Nitta et al.	430	270.1	10/9/2003
/P.T.R./	AC	2002/0160590	10/31/02	Hashimoto et al.	438	528	3/28/2002
/P.T.R./	AF	2003/0170993	9/11/03	Nagahara et al.	438	694	11/26/2002
/P.T.R./	AG	2003/0157806	8/21/03	Nagahara et al.	438	694	12/3/2002

FOREIGN PATENT DOCUMENTS

Examiner's Initials		DOCUMENT NUMBER	DATE	COUNTRY	CLASS	SUB-CLASS	TRANSLATION YES NO
/P.T.R./	AH	11-109654	4/23/99	Japan			Abstract
/P.T.R./	AI	2003-243295	8/29/03	Japan			Abstract
/P.T.R./	AJ	2003-122009	4/25/03	Japan			Abstract
/P.T.R./	AK	2002-359352	12/13/02	Japan			Abstract
/P.T.R./	AL	2003-229481	8/15/03	Japan			Abstract
/P.T.R./	AM	2003-167345	6/13/03	Japan			Abstract
	AN						
	AO						
	AP						

OTHER INFORMATION (Including Author, Title, Date, Pertinent Pages, Etc.)

AQ	
AR	
AS	
EXAMINER: /Ponder Thompson Rummel/	DATE CONSIDERED: 09/29/2008
*EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 609; Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.	

ALL REFERENCES CONSIDERED EXCEPT WHERE LINED THROUGH. /P.T.R.